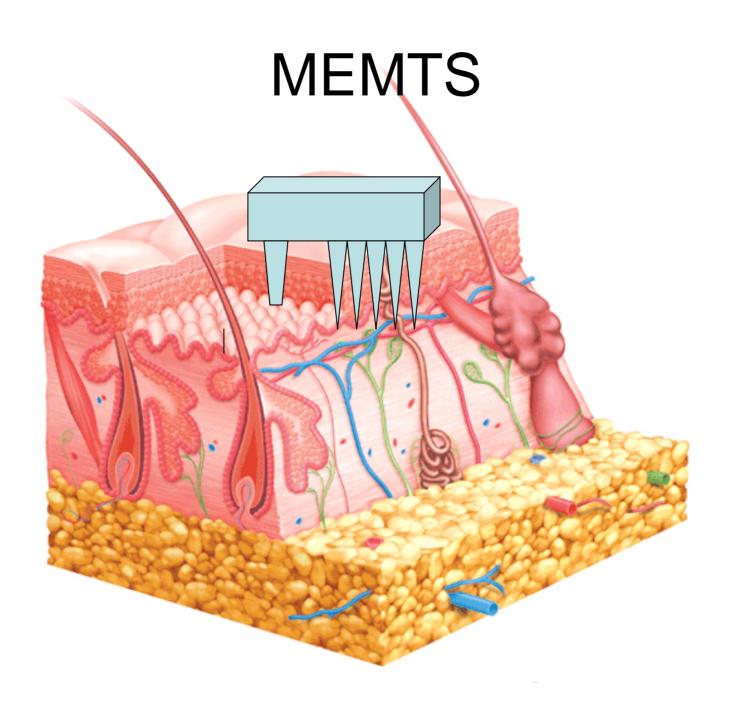
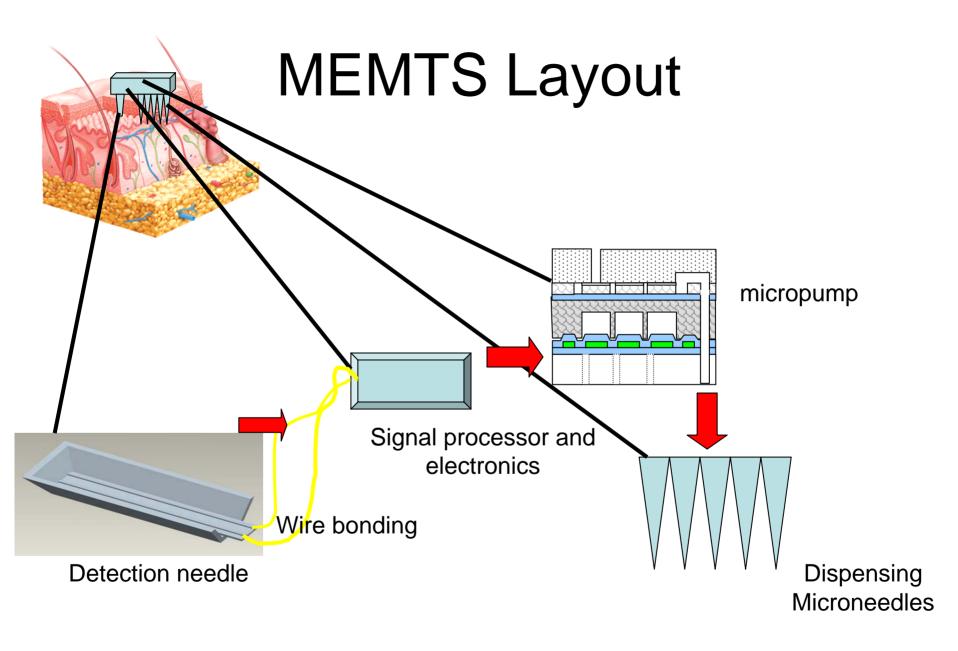
MEM Therapeutic Systems (MEMTS)

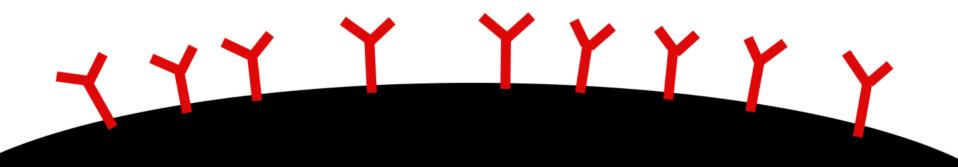
X. "Soy" Chen Russell Hanson Justin Papreck Inho Yoon

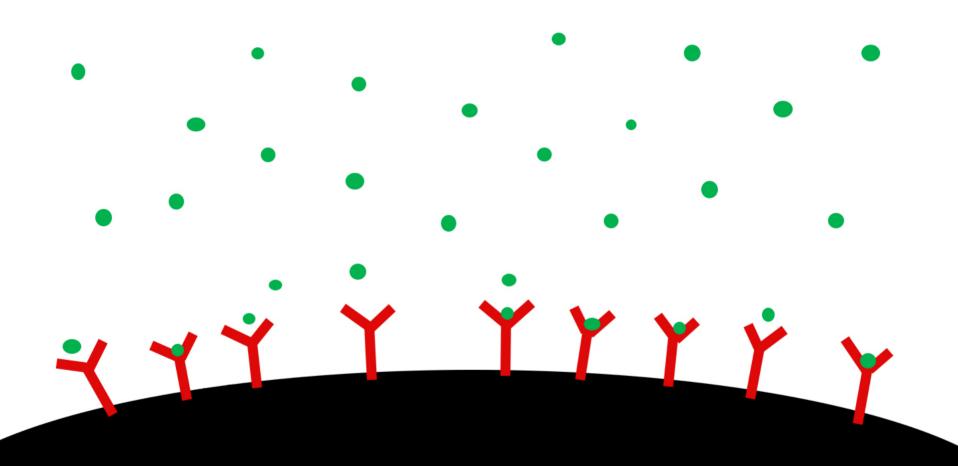
Outline

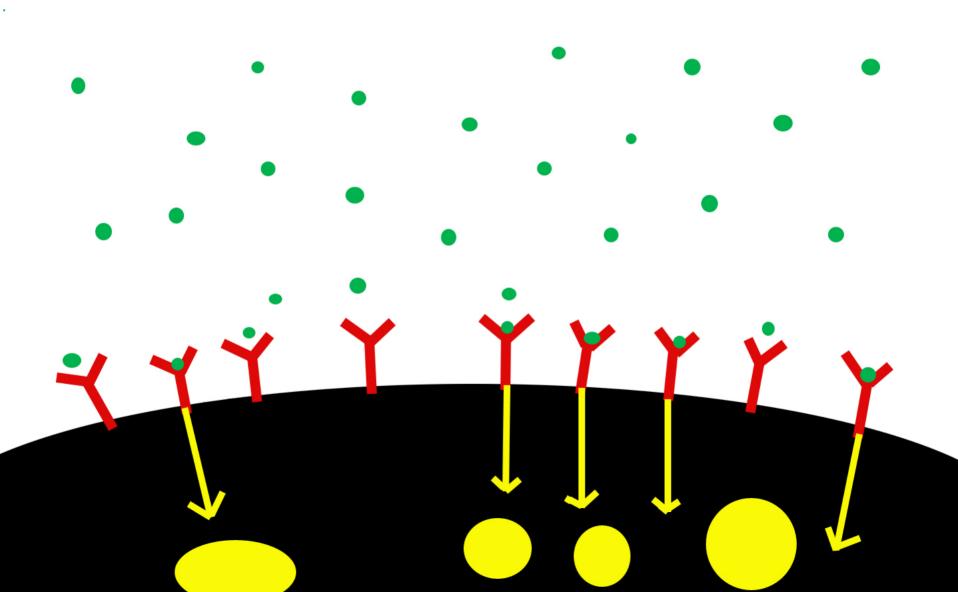
- Clinical Relevance
- Pharmacokinetic Interactions
- MEMTS Performance
- Biochemical Sensor
- Transdermal Microneedle
- Micropump
- Manufacturing Process
- Summary

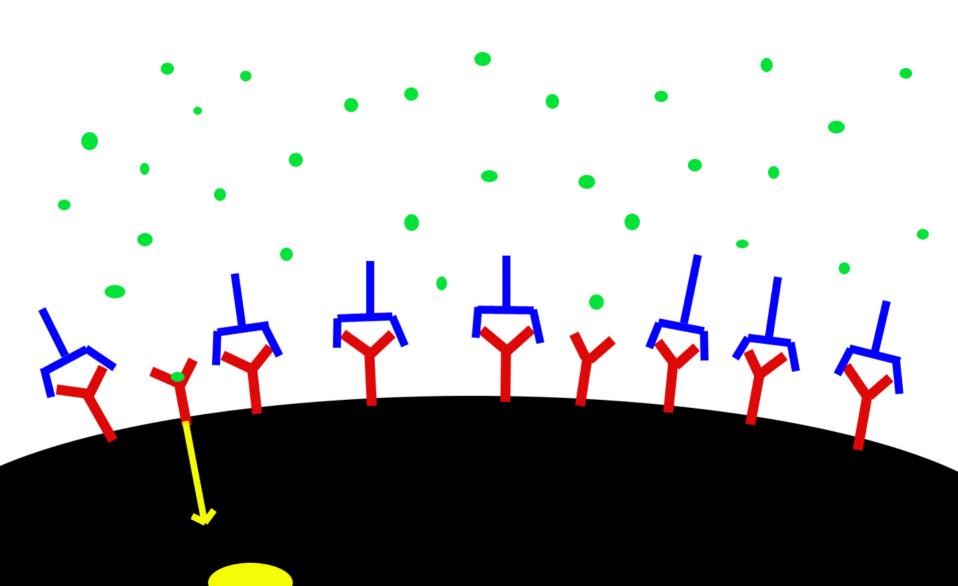


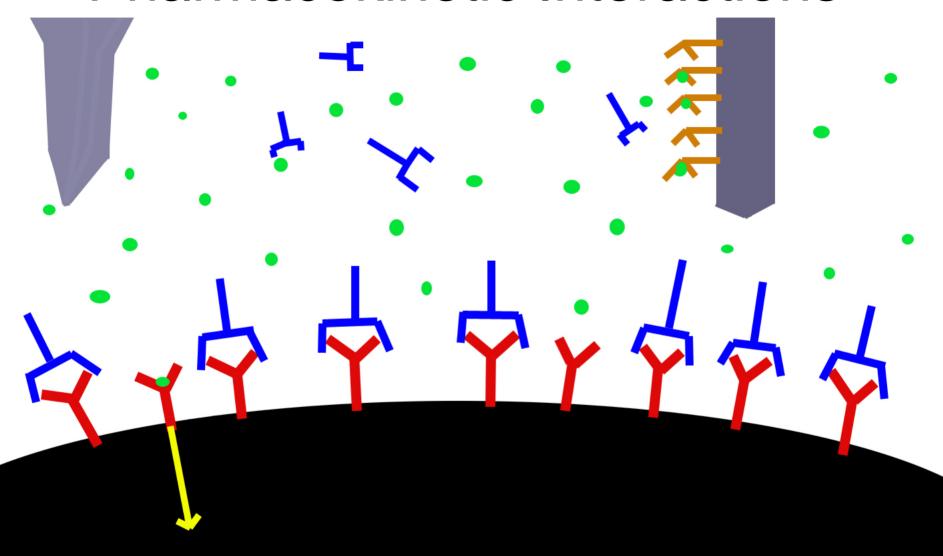


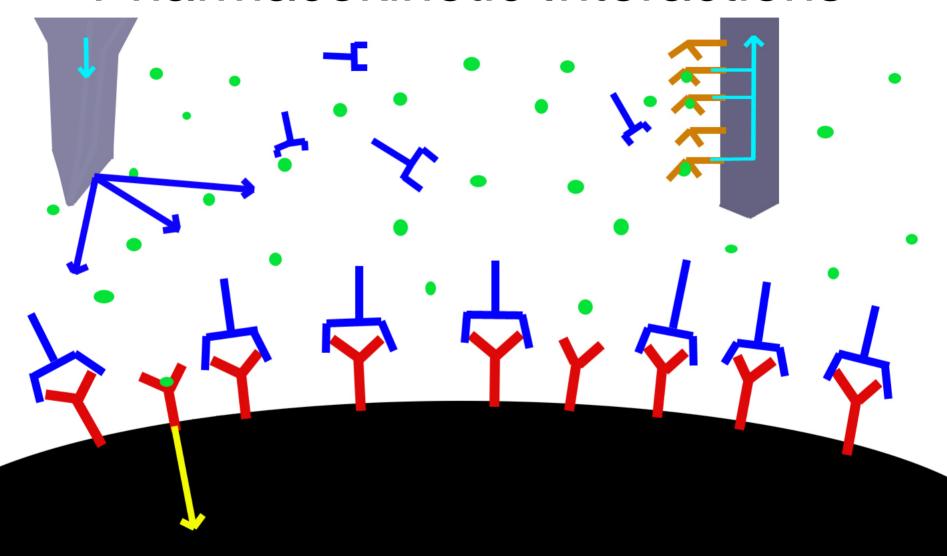


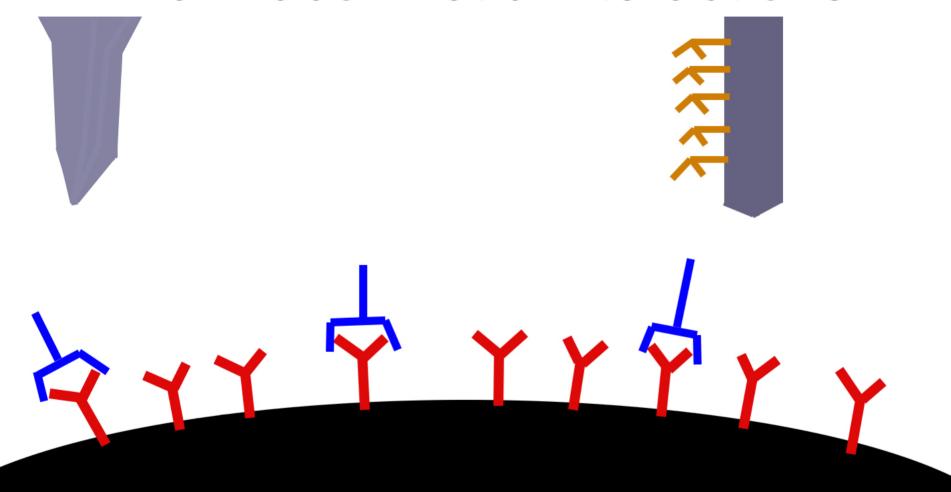




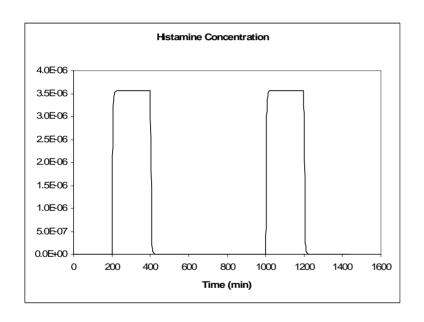


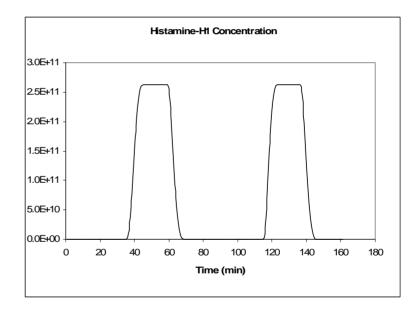




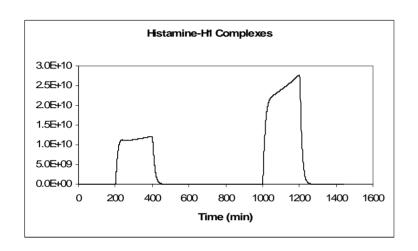


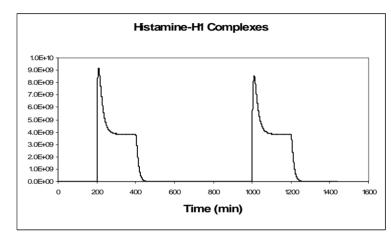
MEMTS Performance

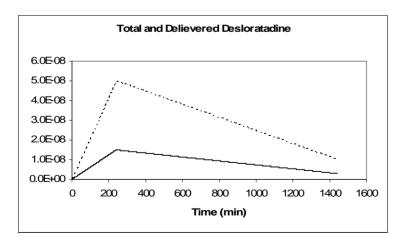


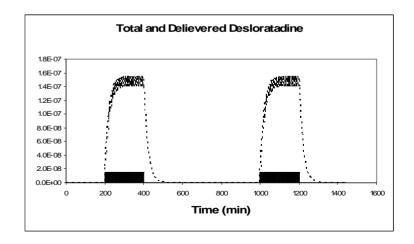


MEMTS Performance









MEMTS Performance

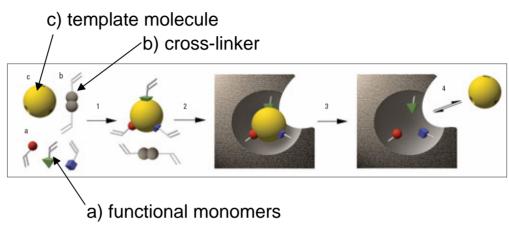
- Sensitivity Analysis
 - System performance is not compromised with detection at or below 5% histamine change (0.2µM blood-histamine)
 - Performance is insensitive to delays up to 2 minutes
 - Optimal response occurred with doses every 4 minutes
 - Duration of delivery was most efficient between 40-50% of the dose period (2 minute delivery in 4 minute release pulses)

MEMTS Performance: Results

- The responsive delivery system elicited a better response than oral delivery, reducing the amount of allergenic interactions by an order of magnitude
- MEMTS delivery also reduced the amount of drug required by 85%

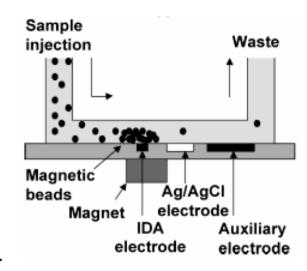
Biochemical sensors - MIPS

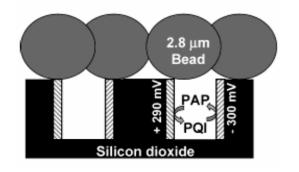
- Molecularly Imprinted Polymers (MIPs)
 - Polymer is very stiff and non-conductive
 - Polymer is washed with 100mL–2L of solvent
 - Small organic and inorganic molecules with few aromatic rings
 - Detection mechanisms: fluorescence, quartzcrystal microbalance (added mass of analyte reduces cantilever vibrational frequency), scintillation, spectral shift, proton release from polymer (pH)
- MIPS have 10³—10⁶ binding sites, biological receptors have ~1.



Biochemical sensors – micro bead

- Bead-Based Electrochemical Detection
 - Biotin attached to rabbit anti-MS2 IgG, coupling antibody to streptavidin-coated beads
 - Potentials of +290 and -300 mV applied to two electrodes, current measured as beads injected
 - PAPG electroinactive at potential where PAP oxidized to PQI -- current proportional to antigen concentration





CNT sensor for protein detection

Add antibodies to CNT surface

Step 1) 1% ethanol, 3-(trimethoxysilyl)propyl aldehyde for 30min; wash with ethanol; heat at 120C for 15min

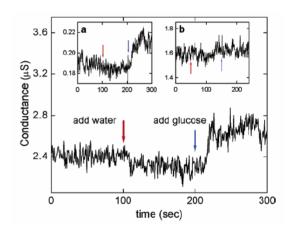
Step 2) Receptors coupled to aldehyde-terminated CNT surface: 10-100µg/mL antibody; 10mM phosphate buffer containing 4mM sodium cyanoborohydride (NaBH₃CN)

(Unreacted CNT aldehyde surface groups passivated by reaction with ethanolamine)

- Direct protein absorption to CNTs
 - Charges on protein surface exert gating effects or charge transfer to nanotube; changes electrical conductance of nanotube FETs.
 - Field effect induced by electrondonating/withdrawing groups; *lysine* residues on protein exterior

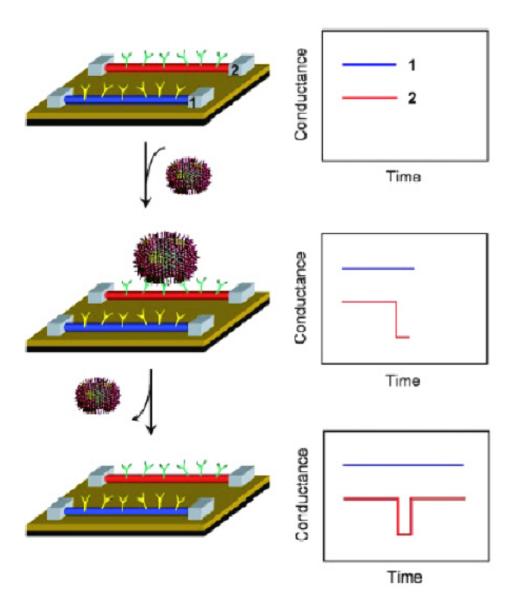
(Chen RJ, J. Am. Chem. Soc., 2004)

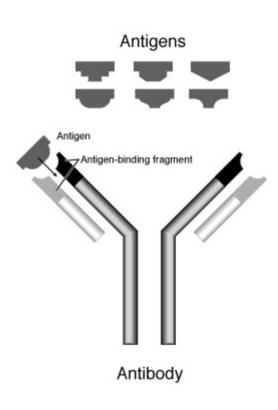
(Patolsky F, PNAS, 2004)



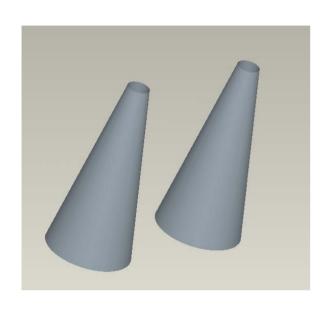
Conductance of glucose oxidase-coated SWNT increases when glucose added (Besteman K, Nano Letters, 2003)

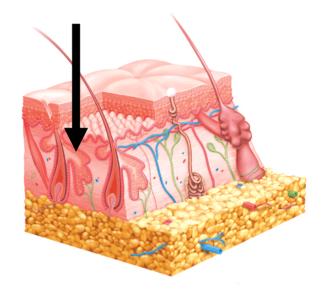
Nanowires for detection





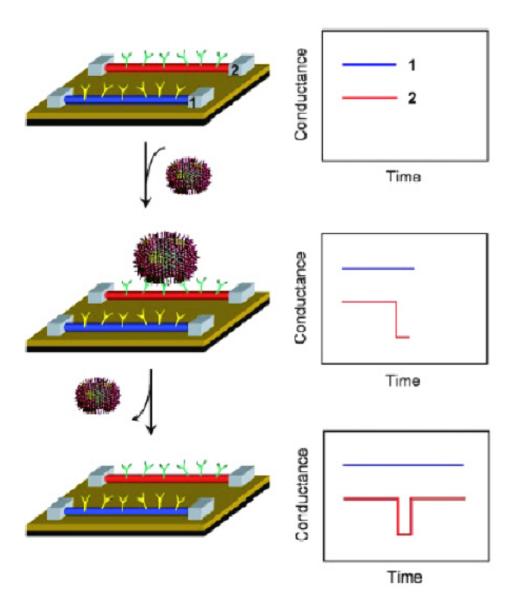
Microneedle Array

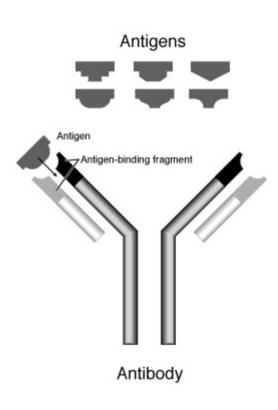




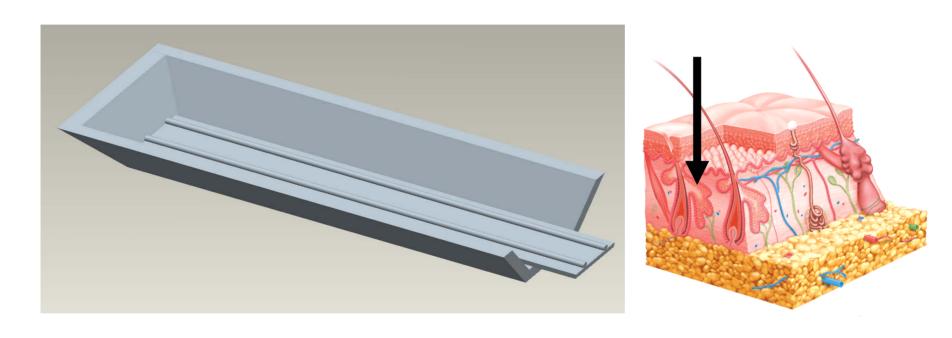
- 500 µm in length for drug delivery beneath epidermis
- 20° angle tip for skin penetration robustness
- sputtered film of biocompatible titanium coating for structural durability

Nanowires for detection





Detection Needle with embedded Nanowires



- minimally invasive tip design
- embedded nanowires in trough for structural reliability
- 700 µm length to penetrate past epidermis

Requirements for Drug Delivery Micropumps

- Flow rate up to 100ul/min
- Self-priming large stroke and small dead volume
- Controllability of flow rate at all time
- Drug compatibility
- No introduction of any toxic particles into the drug and vice versa
- Actuation safety
- The actuation mechanism must not damage and electrolyze the drug.
- Chip size
- Power consumption

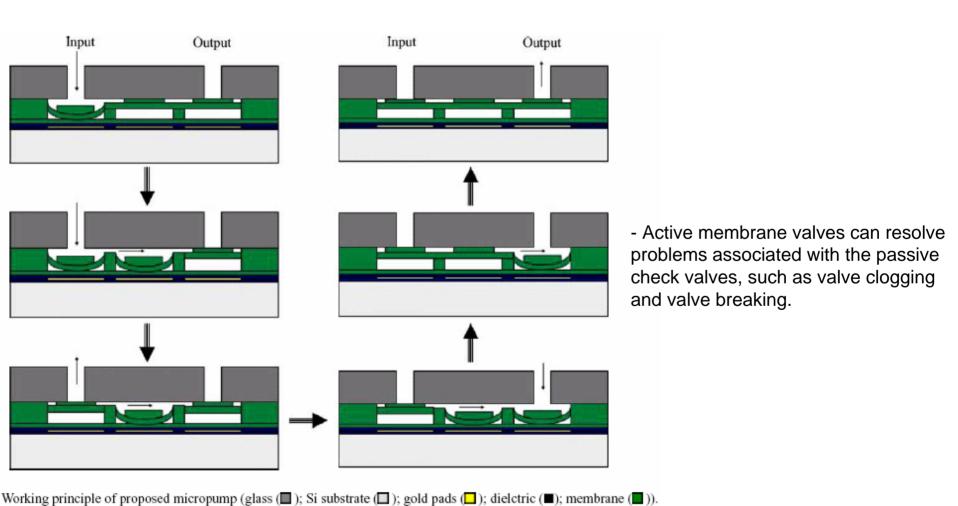
Micro Pumps

- Mechanical Pump
 - Reciprocating type ; Tribological problem
 - Membrane type
 - Two-passive-valve micropump
 - Valve less diffuser/nozzle micropump ;Back flow problem
 - Peristaltic type
 - Reduced valve-leakage and no driven frequency limitation.
 - The actuators are not in contact with liquid.
 - The pumped volume is determined only by the features of the actuator.
 - Rotary type; for high viscous fluid
- Non-mechanical pump

Types of microactuation

- Electrostatic
 - Good reliability and energy efficiency
 - Small displacements
 - Non-linear input & output relationship
- <u>Piezoelectric</u> preferred for medical applications
- Magnetostrictive
 - Affects drug quality, mechanical micropumps
- Thermopneumatic
 - Affects drug quality, mechanical micropumps
- Shape memory alloy

Working principle of proposed micropump



Schematics of the proposed micropump

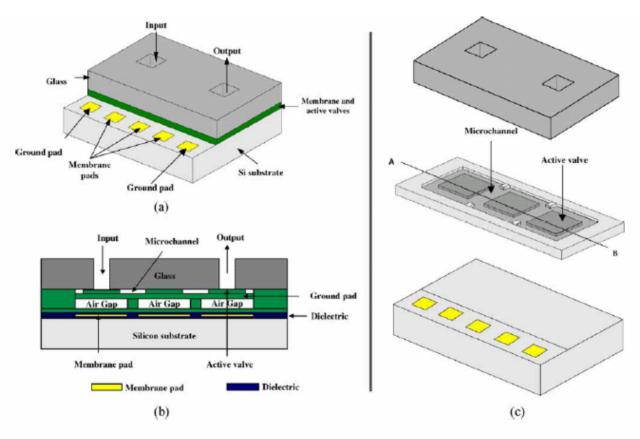
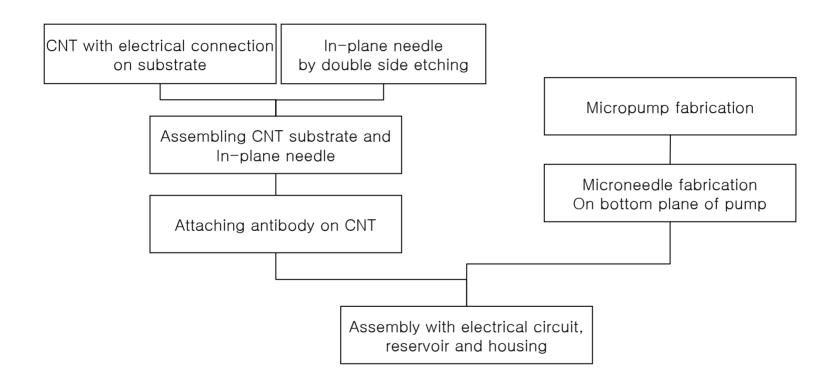
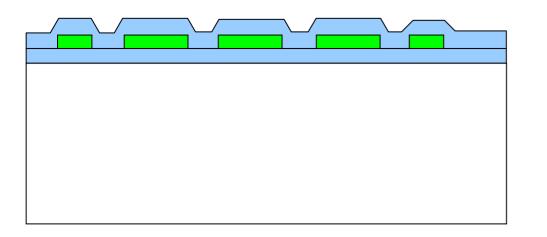


Fig. 1. (a) Three dimentional schematic of the proposed micropump (glass (■); Si substrate (□); gold pads (□); membrane part (■)). (b) Three layers of proposed structure (glass (■); Si substrate (□); gold pads (□); membrane (□); microchannel (□)). (c) Cross-section of the proposed micropump (A–B view) (glass (□); Si substrate (□); gold pads (□); dieletric (■); membrane (■)).

Process Flow Chart





- -A thin Si3N4 is deposited on the Si substrate which act as electrical insulation between pads and substrate.
- -Au is sputtered and then patterned to form electrical pads.
- -A thin Si3N4 is deposited and patterned. It plays the dielectric role between upper and bottom electrodes.

Si Si3N4

Au

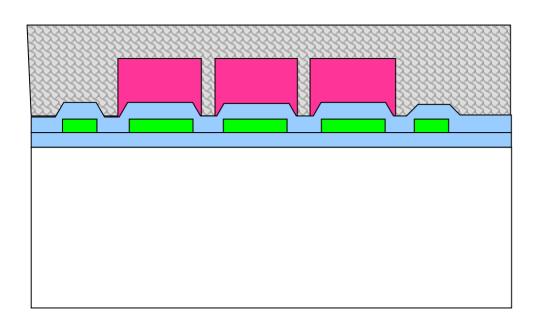
-A 4 um thick photoresist (sacrificial layer) is deposited and patterned. Since, the next processes can affect the photoresist, it is cured in order to resist against high temperature processes

Si

Si3N4

Au

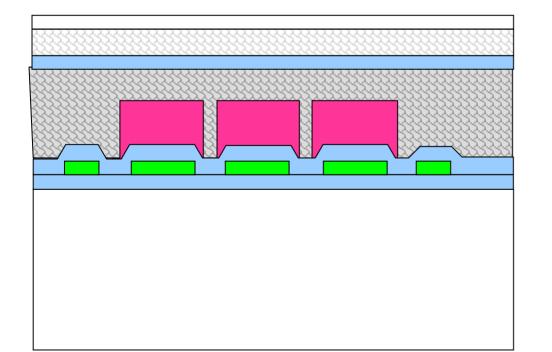
PR



-A 4 um thick p+ doped polysilicon is deposited, planarized, and polished

Si Si3N4 Au PR

P-polySi



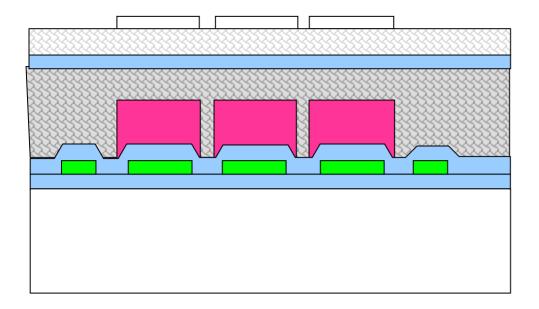
-poly/Si3N4/poly/ SiO2 sandwich layer is deposited. The 2 um polysilicon is the membrane thickness and the 3 um is active valve thickness. SiO2 is used as the selective anodic bonding layer and Si3N4 is used for etch-stop of the polysilicon

Si Si3N4

Au

PR

P-polySi Poly S



-The SiO2 is patterned to be used as the selective anodic bonding layer

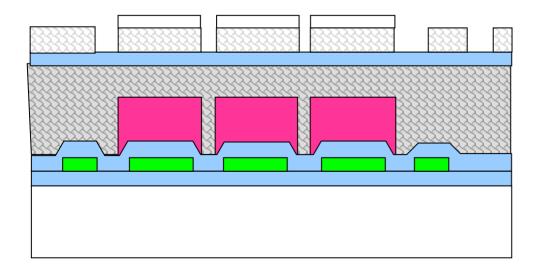
Si

Si3N4

Au

PR

P-polySi



-The polysilicon is patterned. The Si3N4 is used as the mask

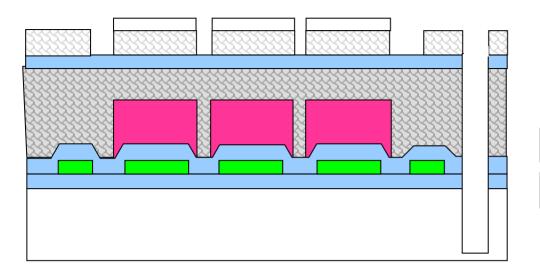
Si

Si3N4

Au

PR

P-polySi Poly Si



-Multi layer etchings for channel between pump and needle

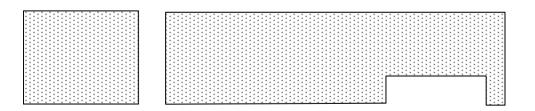








P-polySi



-A hole and a groove are created in the glass substrate which are the input and output ports

Si

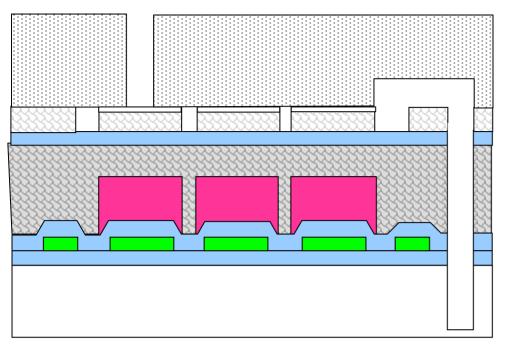






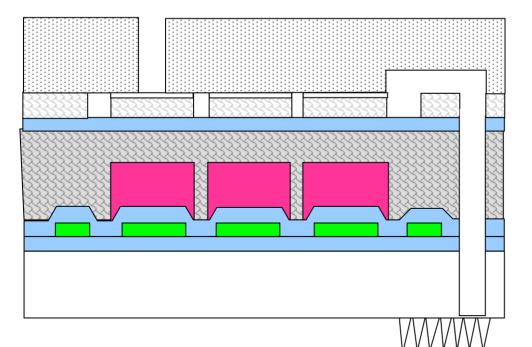
P-polySi Poly Si





-Two substrates are anodically bonded together

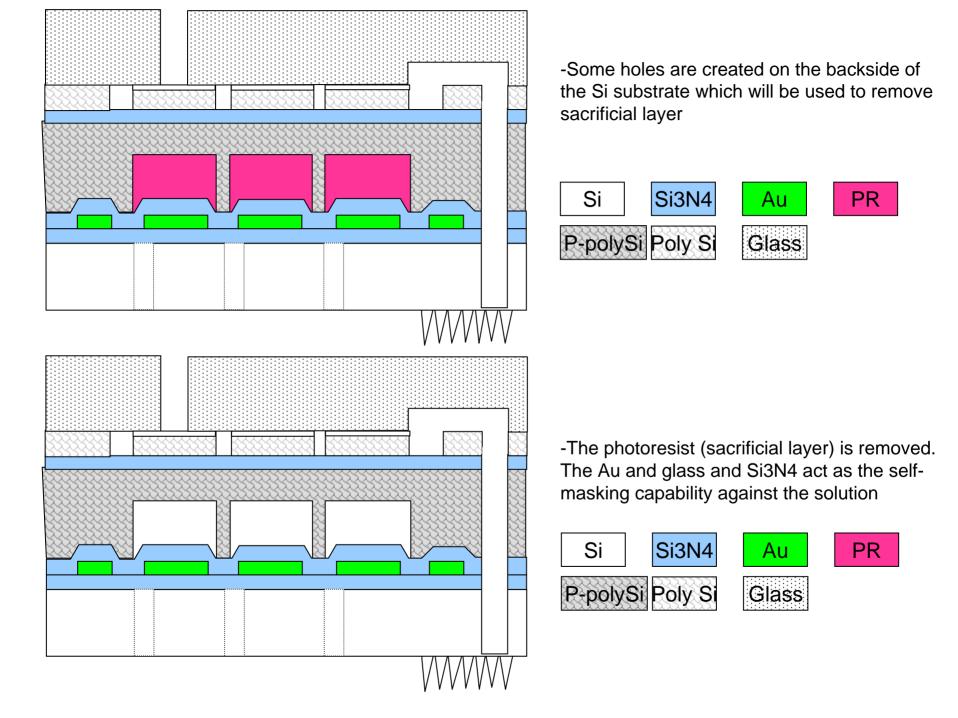




-Needles are fabricated on the bottom plane with etching processes

PR

Si Si3N4 Au
P-polySi Poly Si Glass



Summary

- Clinical Relevance
- Pharmacokinetic Interactions
- MEMTS Performance
- Biochemical Sensor
- Transdermal Microneedle
- Micropump
- Manufacturing Process
- End